EFS-Web Receipt date: 10/06/2006

Docket No.: SHIGA7.046APC

10572709 - G7 5 1795 October 4, 2006 Page 1 of 1

Please Direct All Correspondence to Customer Number 20995

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# TRANSMITTAL LETTER INFORMATION DISCLOSURE STATEMENT

pplicant : Ando et al.

App. No : 10/572,709

Filed : March 17, 2006

For : POSITIVE RESIST COMPOSITION AND

RESIST LAMINATE FOR LOW-

ACCELERATION ELECTRON BEAM AND METHOD OF PATTERN

FORMATION

Examiner : Unassigned

Art Unit : 1752

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 4, 2006

Neil S Startleid Ph.D. Res. No. 39.901

## Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

(X) An Information Disclosure Statement and PTO/SB/08 equivalent listing references for consideration:

(X) Listing 8 references.

(X) Enclosing 7 references.

(X) Return prepaid postcard.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

Neil S. Bartfeld, Ph.D. Registration No. 39,901

Agent of Record Customer No. 20,995 (619) 235-8550

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October 4, 2006

Bartfeld, Ph.D., Reg. No. 39,901

Docket No.: SHIGA7.046APC Customer No. 20,995

policant

### INFORMATION DISCLOSURE STATEMENT

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Ando et al. 10/572,709

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POSITIVE RESIST COMPOSITION AND RESIST LAMINATE FOR LOW-ACCELERATION ELECTRON BEAM

AND METHOD OF PATTERN

FORMATION

Unassigned Art Unit 1752

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450

Examiner

Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 8 references to be considered by the Examiner. Also enclosed are 7 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required. If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Bv:

Respectfully submitted.

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: October 4, 2006

Neil S. Bartfeld, Ph.D. Registration No. 39,901

> Agent of Record Customer No. 20,995 (619) 235-8550

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S-Web eceipt date: 10/06/2006

#### PTO/SB/08 Equivalent TRADE! Application No. 10/572,709 INFORMATION DISCLOSURE Filing Date March 17, 2006 First Named Inventor Tomoyuki Ando STATEMENT BY APPLICANT Art Unit 1752 (Multiple sheets used when necessary) Examiner Unassigned SHEET 1 OF 1 Attomey Docket No. SHIGA7.046APC

U.S. PATENT DOCUMENTS						
Legisla Number - Kind Code (if known) Publication Date Name of Patentee or Applicant Relevant Passa		Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear				
	1	2003/113661 A1	10-05-2001	Sumitomo Chemical Co., Ltd.		

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T <sup>1</sup>
	2	EP 0 588 544 A2	03-23-1994	Urano et al.		
	3	JP 04-340553	11-26-1992	Tanaka Hatsuyuki et al.		Abstract Only
	4	JP 2002-341523	11-27-2002	Sasaki Tomoya et al.		Abstract Only
	5	JP 2002-373845	12-26-2002	Kagami Ichiro		Abstrac Only
	6	JP 2003-177537	06-27-2003	Mizutani Kazuyoshi et al.		Abstract Only
	7	JP 2004-012513	01-15-2004	Endo Masataka et al.		Abstrac Only

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	т¹	
	8	Takao Utsumi. "Low-Energy E-Beam Proximity Lithography (LEEPL): Is the Simplest the Best?" Jpn. J. Appl. Phys. 38(Part 1, No. 12B):7046-7051 (1999).		

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	/Bichard Schilling
vaminer Signature	